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1746

<b>CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)</b> Inventor(s): <b>YOUNG HOON PARK</b>	Docket No. <b>YPL-0019</b>
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Serial No. <b>09/848,533</b>	Filing Date <b>MAY 03, 2001</b>	Examiner <b>MARKOFF, A.</b>	Group Art Unit <b>1746</b>
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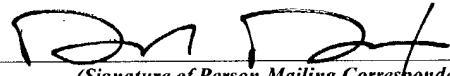
Invention: **ATOMIC LAYER DEPOSITION (ALD) THIN FILM DEPOSITION EQUIPMENT HAVING CLEANING APPARATUS ADN CLEANING METHOD**

**RECEIVED**  
**FEB 09 2004**  
**TC 1700**

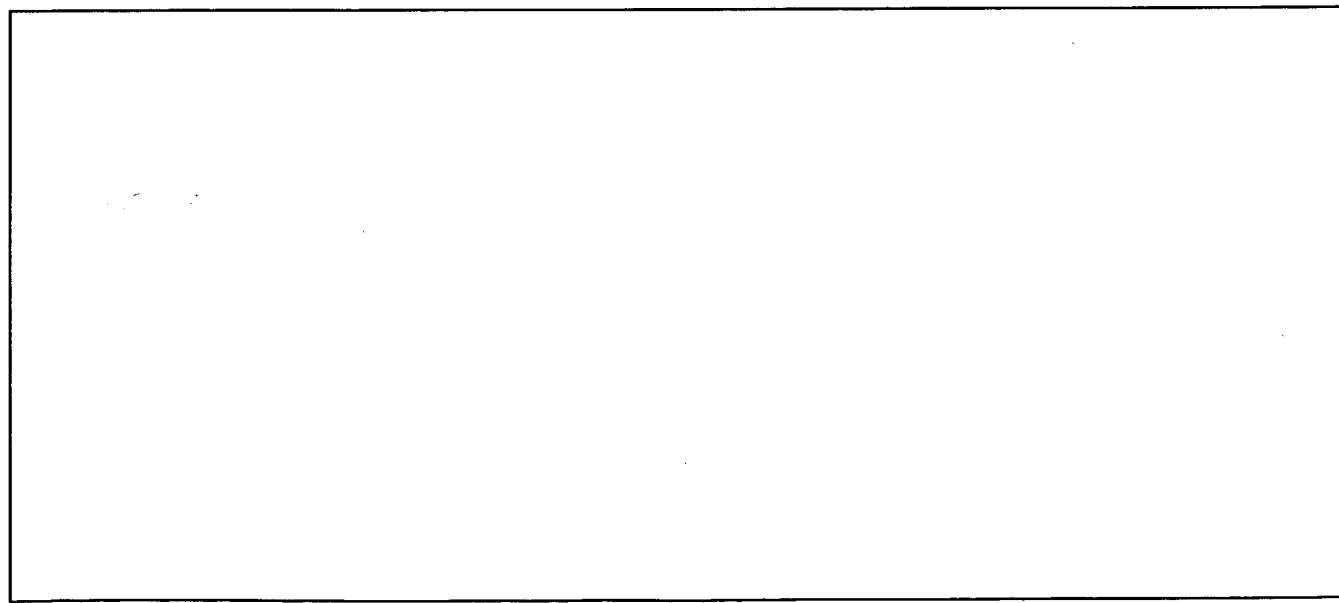
I hereby certify that this **REPLY TO NON-FINAL OFFICE ACTION UNDER 37 CFR 1.111 w/AMENDMENT**  
(Identify type of correspondence)

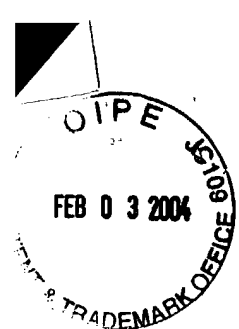
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**DANIEL DREXLER**  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TC 1700

APPLICANT: YOUNG HOON PARK )  
 )Group Art No.: 1746  
SERIAL NO.: 09/848,533 )  
 )Examiner: Markoff, A.  
FILING DATE: May 03, 2001 )  
 )Conf. No. 7524  
FOR: ATOMIC LAYER DEPOSITION (ALD) )  
 THIN FILM DEPOSITION EQUIPMENT )  
 HAVING CLEANING APPARATUS AND )  
 CLEANING METHOD )

**REPLY TO NON-FINAL OFFICE ACTION  
UNDER 37 C.F.R. §1.111, WITH AMENDMENT**

The Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir or Madam:

In response to an Office Action of November 18, 2003, please enter and consider the following:

**Amendment to the Claims**, beginning on page 2 of this paper; and  
**Remarks**, beginning on page 5 of this paper.